

OFFICIAL

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 09/677,478
Filing Date RECEIVED October 2, 2000
Inventor CENTRAL FAX-CENTER Guy T. Blalock
Assignee DEC 18 2003 Micron Technology, Inc.
Group Art Unit 1765
Examiner Lan Vinh
Attorney's Docket No. MI22-1544
Title: Plasma Etching Methods

RESPONSE TO SEPTEMBER 18, 2003 OFFICE ACTION

To: Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

From: D. Brent Kenady
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Wells St. John P.S.
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Responsive to the Office Action dated September 18, 2003, Applicant
amends and remarks as follows:

AMENDMENTS

Underlines indicate insertions and ~~strikeouts~~ indicate deletions.